

Attorney Docket No.: 0180139

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of: Kluth, et al.

Art Unit: 2818

Serial No.: 10/655,179

Examiner: Tran, Long K.

Filed: September 4, 2003

For: **Memory Cell Structure Having Nitride
Layer with Reduced Charge Loss and
Method for Fabricating Same**

RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir/Madam:

This is in response to the Final Office Action dated April 25, 2005 in the above-referenced patent application. Please enter and consider the following remarks.

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